

## PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1  
 Stylesheet Version v1.2

EPAS ID: PAT4829568

<b>SUBMISSION TYPE:</b>	NEW ASSIGNMENT
<b>NATURE OF CONVEYANCE:</b>	ASSIGNMENT
<b>CONVEYING PARTY DATA</b>	
<b>Name</b>	<b>Execution Date</b>
EVATEC ADVANCED TECHNOLOGIES AG	12/07/2017
<b>RECEIVING PARTY DATA</b>	
<b>Name:</b>	EVATEC AG
<b>Street Address:</b>	HAUPTSTRASSE 1A
<b>City:</b>	TRUBBACH
<b>State/Country:</b>	SWITZERLAND
<b>Postal Code:</b>	9477
<b>PROPERTY NUMBERS Total: 6</b>	
<b>Property Type</b>	<b>Number</b>
Application Number:	12329064
Application Number:	13258576
Application Number:	13859854
Application Number:	14452883
Application Number:	14400145
Application Number:	14424172
<b>CORRESPONDENCE DATA</b>	
<b>Fax Number:</b>	(216)579-6073
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
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<b>ATTORNEY DOCKET NUMBER:</b>	TSW-J1049
<b>NAME OF SUBMITTER:</b>	MICHAEL W. GARVEY
<b>SIGNATURE:</b>	/michaelwgarvey/
<b>DATE SIGNED:</b>	02/19/2018
<b>Total Attachments: 3</b>	

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**PATENT**

**REEL: 044965 FRAME: 0062**

## ASSIGNMENT

THIS ASSIGNMENT is made this 31 day of October, 2017.

Between:

Evatec Advanced Technologies AG, a corporation, and having a place of business at Iramali 18, 9496 Balzers, Liechtenstein (hereinafter called the Assignor) and

Evatec AG, a corporation, and having a place of business at Hauptstrasse 1a, 9477 Trübbach, Switzerland (hereinafter called the Assignee)

WHEREAS, the Assignor is the owner of patents and patent applications, short particulars of which are set out in Schedule A attached hereto.

WHEREAS, Assignee is desirous of acquiring all the rights in and to the patents.

WHEREAS, good and valuable consideration has been exchanged between the Assignor and the Assignee and the consideration was sufficient.

NOW, THEREFORE, be it known that, for the valuable consideration, the receipt and sufficiency of which are hereby acknowledged, the Assignor does hereby:

- 1- Assign to the Assignee, its successor and assigns, all property, right, title and interest to the patents and including the right to sue for damages and other remedies in respect of any infringement which may have occurred prior to the date hereof.
- 2 - Covenant to execute all documents, forms and authorizations and depose to or swear any declaration or oath as may reasonably be required for absolutely vesting full right, title and interest in the patents in favor of the Assignee.

IN WITNESS WHEREOF this Assignment has been executed by or on behalf  
of the parties hereto on the date first written above.

Signed for and on behalf of  
Evatec Advanced Technologies AG

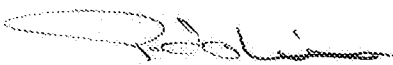
  
Andreas Wirth  
CEO

Name:

Title:

NAOJA JOUNI  
Witness

FLAVIA HAUZ  
Witness

  
Peter Lippuner  
CEO

Name:

Title:

NAOJA JOUNI  
Witness

FLAVIA HAUZ  
Witness

**SCHEDULE A**

**Patents Applications**

<b><u>SERIAL NO.</u></b>	<b><u>TITLE</u></b>
12/329,064	REACTIVE SPUTTERING WITH HIPIMS P209024
13/258,576	REACTIVE SPUTTERING WITH MULTIPLE SPUTTER SOURCES
13/859,854	RF SUBSTRATE BIAS WITH HIGH POWER IMPULSE MAGNETRON SPUTTERING (HIPIMS) P212360
14/452,883	METHOD FOR MANUFACTURING WORKPIECES AND APPARATUS P213515
14/400,145	ADAPTER FOR VACUUM-INSULATED LINES P214813
14/424,172	PROCESSING ARRANGEMENT WITH TEMPERATURE CONDITIONING ARRANGEMENT AND METHOD OF PROCESSING A SUBSTRATE P214821

P21265